



Microsystem Technologies

Micro- and Nanosystems Information Storage and Processing Systems

Editors-in-Chief: B. Michel; B. Bhushan

- ▶ Examines electromechanical, materials, design, and manufacturing issues of microsystems and their components
- ▶ Integrates the knowledge, experience, and capabilities of academic and industrial specialists in many fields
- ▶ Contributes to the economically and ecologically sound production of reliable, high performance MEMS and information storage and processing systems
- ▶ 95% of authors who answered a survey reported that they would definitely publish or probably publish in the journal again

Featuring rapid publication of important results, *Microsystem Technologies* examines electromechanical, materials, design, and manufacturing issues of microsystems and their components. It integrates the knowledge, experience, and capabilities of academic and industrial specialists in many fields. Moreover, it contributes to the economically and ecologically sound production of reliable, high performance MEMS and information storage and processing systems.

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